



Attorney Docket No. 5649-1144

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Koh et al.

Application Serial No.: 10/625,452

Filed: July 23, 2003

For: *Methods of Forming Semiconductor Devices Using an Etch Stop Layer*

Confirmation No.: 7953

Group Art Unit: 1765

Examiner: Lan Vinh

Date: May 9, 2006

Mail Stop RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT ACCOMPANYING  
REQUEST FOR CONTINUED EXAMINATION

Sir:

Applicants provide the present Amendment to address the issues raised in the Office Action mailed November 10, 2005.

A listing of the Claims begins on page 2 of this paper

Remarks begin on page 7 of this paper.

It is not believed that an extension of time and/or additional fee(s), including fees for net addition of claims, are required, beyond those that may otherwise be provided for in documents accompanying this paper. In the event, however, that an extension of time is necessary to allow consideration of this paper, such an extension is hereby petitioned under 37 C.F.R. §1.136(a). Any additional fees believed to be due in connection with this paper may be charged to our Deposit Account No. 50-0220.